

United States Patent [19]

Wakita et al.

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[54]	METHOD OF MANUFACTURING ORGANIC ORIENTED FILM AND METHOD OF MANUFACTURING ELECTRONIC DEVICE			
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[52] U.S. Cl. 117/84; 117/925; 117/927

[58] Field of Search 117/925, 927,

117/84

[56] **References Cited**

U.S. PATENT DOCUMENTS

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[57] **ABSTRACT**

A method of manufacturing an organic electronic device having a substrate and a pair of electrodes facing each other, including the steps of forming a polytetrafluoroethylene oriented film on a substrate, and contacting an oligothiophene compound with the polytetrafluoroethylene oriented film to form an organic oriented film on the polytetrafluoroethylene oriented film between the pair of electrodes wherein the long axis of oligothiophene molecules is oriented to the orientation of the polytetrafluoroethylene oriented film and crystallized.

16 Claims, 9 Drawing Sheets

